## Optical, structural and hydrogen sensing properties of **TiO<sub>2</sub>** thin films

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 An optimization of DC Magnetron Reactive Sputtering parameters is in progress to decrease the operating temperature of TiO<sub>2</sub> thin films and cut down the response time of the developed sensors

nm Pt (higher sensitivity and faster response).

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TiO<sub>2</sub> surface was prohibited.

·TiO<sub>2</sub> samples with 1 and 3 nm Pt surface modification were tested towards hydrogen concentrations 10000, 5000, 2000 and 1000 ppm at 180, 190 and 200 °C

TiO<sub>2</sub> thin films with 1 nm Pt

TiO<sub>2</sub> thin films with 3 nm Pl

